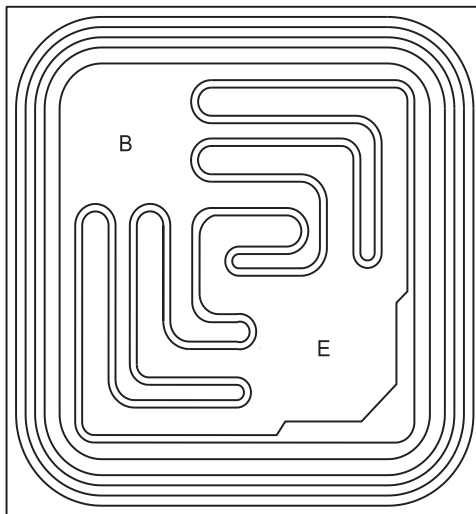


**PROCESS DETAILS**

|                          |                  |
|--------------------------|------------------|
| Process                  | EPITAXIAL PLANAR |
| Die Size                 | 19.8 x 19.8 MILS |
| Die Thickness            | 9.5 MILS         |
| Base Bonding Pad Area    | 4.3 x 4.3 MILS   |
| Emitter Bonding Pad Area | 4.3 x 4.3 MILS   |
| Top Side Metalization    | Al - 30,000Å     |
| Back Side Metalization   | Au - 12,000Å     |

**GEOMETRY**



BACKSIDE COLLECTOR

**GROSS DIE PER 4 INCH WAFER**

28,960

**PRINCIPAL DEVICE TYPES**

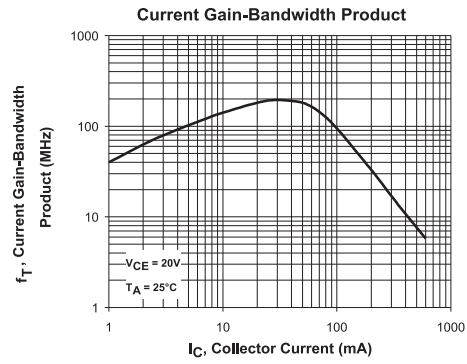
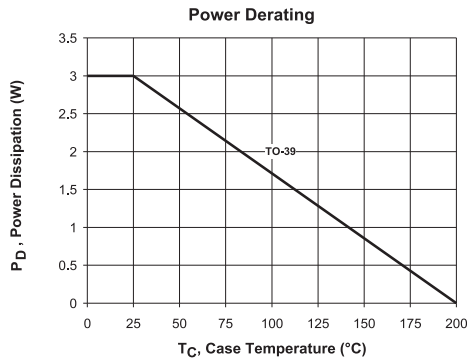
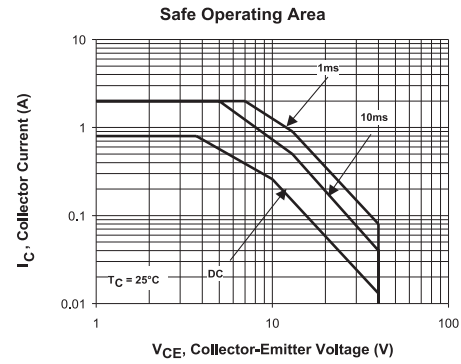
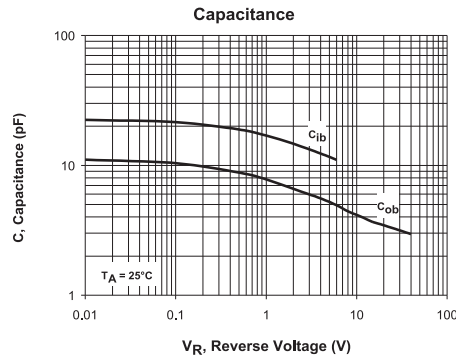
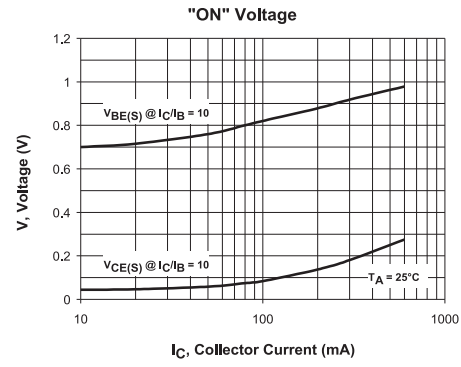
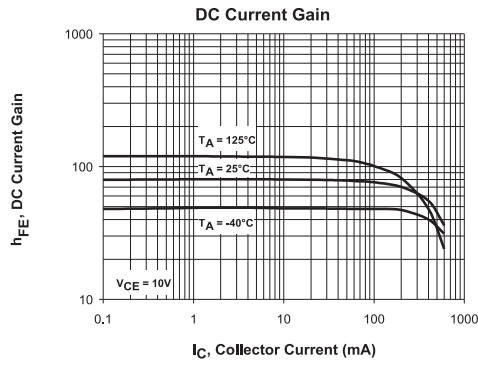
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